930055-2036	
FLH Docket No.	

DECLARATION FOR PATENT APPLICATION AND POWER OF ATTORNEY

(Under 37 CFR § 1.63; includes reference to PCT International Applications)

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention ENTITLED:

PIEZOELECTRIC THIN FILM DEVICE AND METHOD OF PRODUCING THE SAME

the specification	n of which:				
	PCT Application No. I and designating the U. with amendments thro	Continuation or PCT/JP2004/004 .S., and published ough even date	Continuation-in-Part or Diversity 507, filed March 30, 2004 das WO 2004/088840 A1 of the contents of the above	on <u>October 14.</u> e, give details).
			d States Patent and Tradema n Title 37, Code of Federal l		
application(s) for one country oth application for p country other th	or patent or inventor's c er than the United State patent or inventor's cert	ertificate or of an e of America listo lificate or any PC America filed b	Title 35, United States Code in PCT International applicated below and have also identify International applications we on the same subject mained:	tion(s) design ified below an designating at	ating at lea 1y foreign 1 least one
Prior Foreign/P	CT Application(s) [list	additional applic	cations on separate page]:	Daionity (Tloimed.
Country (or Japan		on Number: 094372	Filed (Day/Month/Year) 31/03/2003	Priority C Yes C	No
I hereby	claim the benefit unde	er 35 U.S.C. §119	9(e) of any United States app	olication listed	below:
(Applic	ation Number)	(Filing Date)			
			d States Code § 120 of any U		

I hereby claim the benefit under Title 35, United States Code § 120 of any United States application(s) or PCT international application(s) designating the United States of America that is/are listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in that/those prior application(s) in the manner provided by the first paragraph of Title 35, United States Code § 112, I acknowledge the duty to disclose to the United States Patent and Trademark Office all information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

Prior U.S. (or U.S.-designating PCT) Application(s) [list additional applications on separate page]:

U.S. Serial No.: Filed (Day/Month/Year) PCT Application No. Status (patented, pending, abandoned)

I hereby appoint Ronald R. Santuckegistration No. 28,988, and Frommer Lawrence & Haug LLP, or their duly appointed associate, my attorneys, with full power of substitution and revocation, to prosecute this application, to make alterations and amendments therein, to file continuation and divisional applications thereof, to receive the Patent, and to transact all business in the Patent and Trademark Office and in the Courts in connection therewith, and to insert the Serial Number of the application in the space provided above, and specify that all communications about the application are to be directed to the following correspondence address:

Ronald R. Santucci, Esq. c/o FROMMER LAWRENCE & HAUG LLP 745 Fifth Avenue New York, NY 10151

Citizenship:

Direct all telephone calls to: (212) 588-0800 to the attention of: Ronald R. Santucci

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

the validity of the application of any p	patent issued thereon.		·			
INVENTOR(S):						
Signature: Keigo	Nagao	Date:	September 22, 2005			
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Signature: Xosuke ?	Viskimmen	Date:	September 22, 2005			
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Citizenship.	Japanese					
		• •				
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FLH Docket No. __

September 22, 2005

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